

INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number	10/038,745	
		Filing Date	January 2, 2002	
		First Named Inventor	Robert Jackson	
		Group Art Unit	1754	
		Examiner Name	Ngoc Nguyen	
Sheet 1	of 1	Attorney Ref. Number	FOC1100-1	
NON-PATENT LITERATURE DOCUMENTS				
<i>yr</i>	C6	International Search Report for PCT/US02/37912 mailed July 23, 2003.		
Examiner Signature	<i>Ngoc Nguyen</i>		Date Considered	12/09/04

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GROUP 1705

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ATTY DOCKET NO.:

FOC1100-1

SERIAL NO.:

10/038,745

**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT BY
APPLICANT**

APPLICANT(S):

Robert Jackson

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PATENT NO. OF PARENT:

n/a

ISSUE DATE OF PARENT:

n/a



U.S. PATENT DOCUMENTS

EXAM. INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE	
<i>jm</i>	A24	2,879,212	03/24/59	Hill, et al.	204	60	12/19/55
	A25	3,146,179	08/25/64	Davies	204	60	03/15/62
	A26	3,684,667	08/15/72	Sayce	204	60	07/27/70
	A27	4,125,443	11/14/78	Grant, et al.	204	60	09/29/77
	A28	4,176,018	11/27/79	Faron, et al.	204	60	11/03/78
	A29	4,312,718	01/26/82	Watanabe, et al.	204	60	06/20/80
	A30	4,900,395	02/13/90	Syverson, et al.	156	639	04/07/89
	A31	4,960,488	10/02/90	Law, et al.	156	643	12/19/89
	A32	5,002,632	03/26/91	Loewenstein, et al.	156	643	11/22/89
	A33	5,298,112	03/29/94	Hayasaka, et al.	156	643	12/15/92
	A34	5,378,324	01/03/95	Hodgson	204	60	04/02/93
	A35	5,405,491	04/11/95	Shahvandi, et al.	156	643	03/04/94
	A36	5,597,495	01/28/97	Keil, et al.	216	66	11/07/94
	A37	5,705,080	01/06/98	Leung, et al.	216	67	07/06/94
	A38	5,762,813	06/09/98	Takiyama, et al.	216	67	03/13/96
	A39	5,846,886	12/08/98	Hattori, et al.	438	740	02/28/97
	A40	5,849,639	12/15/98	Molloy, et al.	438	714	11/26/97
<i>jm</i>	A41	5,872,061	02/16/99	Lee, et al.	438	705	10/27/97
	A42	5,880,031	03/09/99	Wong	438	706	06/25/92

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<i>yn</i>	A43	5,880,032	03/09/99	Doi, et al.	438	706	07/30/99
	A44	5,888,309	03/30/99	Yu	134	1.2	12/29/97
	A45	5,904,566	05/18/99	Tao, et al.	438	689	06/09/97
	A46	5,935,874	08/10/99	Kennard	438	710	03/31/98
	A47	5,970,376	10/19/99	Chen	438	637	12/29/97
	A48	5,980,769	11/09/99	Yanagisawa, et al.	216	67	11/06/97
	A49	6,007,733	12/28/99	Jang, et al.	216	80	05/29/98
	A50	6,024,887	02/15/00	Kuo, et al.	216	48	06/03/97
	A51	6,024,888	02/15/00	Watanabe, et al.	216	73	11/13/96
<i>yn</i>	A52	6,051,505	04/18/00	Chu, et al.	438	710	03/05/98

FOREIGN PATENT DOCUMENTS

EXAM. INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES/NO)
	B1					
	B2					

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

	C1	
	C2	

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U.S. PATENT DOCUMENTS

EXAM. INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
<i>yn</i>	A1	3,976,447	8/24/76	Merchant, et al.	55	71	3/11/75
	A2	4,960,488	10/2/90	Law, et al.	156	643	12/19/89
	A3	5,207,836	5/4/93	Mei Chang	134	1	6/3/92
	A4	5,336,832	8/9/94	Alfred E. Keller	585	710	11/6/92
	A5	5,549,802	8/27/96	Xin S. Guo	204	298.11	10/24/94
	A6	5,565,038	10/15/96	Ethan Ashley	134	2	5/16/91
	A7	5,685,916	11/11/97	Ye, et al.	134	1.1	7/7/95
	A8	5,756,400	5/26/98	Ye, et al.	438	710	12/8/95
	A9	5,788,778	8/4/98	Shang, et al.	134	1	9/16/96
	A10	5,788,799	8/4/98	Steger, et al.	156	345	6/11/96
	A11	5,844,195	12/1/98	Fairbairn, et al.	219	121.43	11/18/96
	A12	6,020,035	2/1/00	Gupta, et al.	427	534	10/29/96
	A13	6,029,718	2/29/00	Jackson, et al.	141	231	6/26/98
	A14	6,109,206	8/29/00	Maydan, et al.	118	723IR	5/29/97
	A15	6,159,333	12/12/00	Gupta, et al.	156	345	10/8/98
	A16	6,255,222	7/3/01	Xia, et al.	438	710	8/24/99
	A17	6,264,852	7/24/01	Herchen, et al.	216	60	6/16/00
	A18	6,271,148	8/7/01	Kao, et al.	438	727	10/13/99
<i>yn</i>	A19	6,352,081	3/5/02	Lu, et al.	134	22.1	7/9/99

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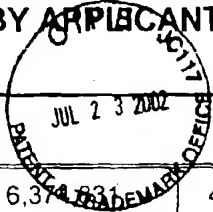
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yn	A20	6,374,831	4/23/02	Chandran, et al.	134	1.1	2/4/99
	A21	6,379,575	4/30/02	Yin, et al.	216	67	10/21/97
	A22	6,387,288	5/14/02	Bjorkman, et al.	216	67	4/21/00
yn	A23	2002/0074013A1 09/741,529	published 6/20/02	Shang, et al.	134	1.1	12/19/00

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EXAM. INITIALS		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES/NO)
yn	B1	EP0697467A1	21.02.1996	Europe	C23C	16/44	Yes
	B2	WO 99/06611	11.02.1999	WO	C23C	16/44	Yes
	B3	WO 99/28538	10.06.1999	WO	C25B	9/00	Yes
	B4	EP0965661A2	22.12.1999	Europe	C25B	9/00	Yes
yn	B5	EP1076355A2	14.02.2001	Europe	H04L	21/00	Yes

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

yn	C1	<i>Kinetics of Gaseous Fluorine Reactions</i> , by Rudy Toon and Myron Kaufman. Progress in Reaction Kinetics, 1975, Vol. 8, No. 2, pp. 81-93
yn	C2	VLSI Technology, Sze, Section 8.3 - Dry Etching, McGraw-Hill Book Co., pp. 312-317 (1983)
yn	C3	MKS ASTeX® Products Announces ASTRON®e Ser High Flow Reactive Gas Generators for Process Chamber Cleaning Applications, Information printed from website www.astex.com/prastrone.html (2001)

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